

Group Art Unit: 2886  
Confirmation No.: 3799  
Examiner: Nur, A.

Atty. Ref.: F04-018US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Tohru Koike et al.  
Appl. No. : 10/575,714  
Filed : May 8, 2006  
For : METHOD FOR MEASURING A SURFACE PLASMON  
RESONANCE AND NOBLE METAL COMPOUND USED FOR THE  
SAME

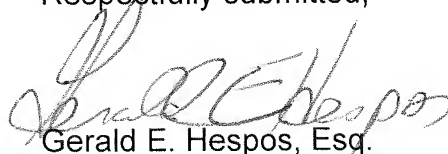
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FOURTH INFORMATION DISCLOSURE STATEMENT**

Sir:

Office Actions issued in connection with Japanese patent applications that are related to the above-identified US patent application. These Office Actions are not prior art, and hence are not listed on Form PTO/SB/08A. Neither of the Office Actions applies any prior art to the claims. Rather, both Office Actions relate to the appropriateness of the claims pending in divisional applications in Japan. The Examiner is invited to consider the comments of the respective Japanese Examiners.

Respectfully submitted,



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